

JPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2892
Examiner: Mr. William F. Kraig

In re PATENT APPLICATION of:

Applicant	:	Akira TAKAHASHI)	
)	
Serial No.	:	10/798,482)	<u>LETTER</u>
)	
Filed	:	March 12, 2004)	
)	
For	:	DRY ETCHING METHOD FOR)	
		SEMICONDUCTOR DEVICE)	
)	
Attorney Ref.	:	OKI 414)	

July 21, 2009

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

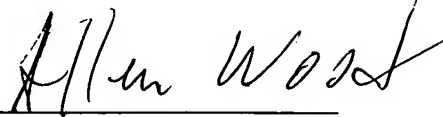
It is noted that a paper entitled "Response" was filed on April 21, 2009 in reply to an Office Action dated January 21, 2009. A paper entitled "Petition" was filed at the same time. A reply to either the Response or the Petition has not yet been received. Furthermore, neither document had yet been posted in the "Transactions History" section of PAIR (although the documents themselves are present in the "Image File Wrapper" section). This anomaly suggests that they may have been misplaced at the Patent and Trademark Office. Accordingly, copies are attached hereto for use in the event that the originals were indeed lost or that some other mishap has occurred. Also attached is a copy of our postcard filing receipt for the Response and the Petition. It bears the Patent and Trademark Office's stamp for April 21, 2009.

It is believed that no extension of time is needed with the present Letter, since the Response was filed within the three-month period set by the Office Action of January 21, 2009. Nevertheless, Applicant hereby provisionally petitions for any extensions that may be deemed

necessary to avoid abandonment. The extension fee can be charged to our Deposit Account number 18-0002.

Continued examination is respectfully requested.

Respectfully submitted,

A handwritten signature in cursive script that reads "Allen Wood". The signature is written in dark ink and is positioned above a horizontal line.

Allen Wood
Registration No. 28,134
Customer number 23995
Rabin & Berdo, P.C.
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AW/ng



COPY

Receipt No.: 37034

Atty. ref.: OKI 414
Date: April 21, 2009

Applicant(s): Akira TAKAHASHI

Serial No.: 10/798,482

Filed: March 12, 2004

For: DRY ETCHING METHOD FOR SEMICONDUCTOR
DEVICE

Papers Filed:

- Response (6 pages)
- Petition (4 pages)



Fee(s): \$0.00

****PLEASE DATE-STAMP POSTCARD AND RETURN****